INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 17, 2026

IGI Report Number	LG847678557
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	9.75 X 6.93 X 4.78 MM

GRADING RESULTS

Carat Weight	3.14 CARATS
Color Grade	E
Clarity Grade	VVS 2

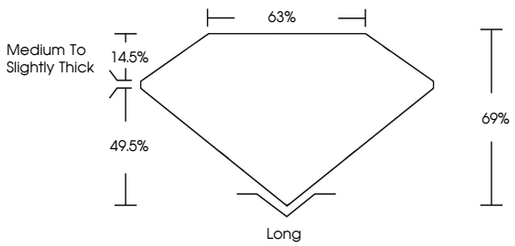
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG847678557

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG847678557
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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GRADING RESULTS
Carat Weight 3.14 CARATS
Color Grade E
Clarity Grade VVS 2

63%
Medium To Slightly Thick
14.5%
49.5%
69%
Long

ADDITIONAL GRADING INFORMATION
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG847678557
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

IGI

October 17, 2026
IGI Report No LG847678557
EMERALD CUT
9.75 X 6.93 X 4.78 MM
Carat Weight 3.14 CARATS
Color Grade E
Clarity Grade VVS 2
Depth 69%
Table 63%
Girdle Medium To Slightly Thick
Culet Long
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG847678557
Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa